

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF:

Jaehwan EUN, et al.

CONFIRMATION NO.: 1951

FILED: June 17, 2005

GROUP ART UNIT:

SERIAL NO. 10/539,886

EXAMINER:

FOR: Method For Preparing Film Structure Comprising Ferroelectric Single Crystal Layer

INFORMATION DISCLOSURE STATEMENT

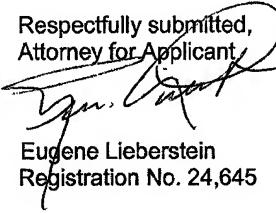
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The Information Disclosure Statement is being filed to officially make of record the references, with English abstracts thereof, cited in the attached PTO/SB/08A attached hereto.

Respectfully submitted,
Attorney for Applicant



Eugene Lieberstein
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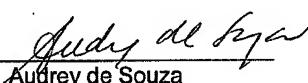
Dated: March 14, 2007

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Audrey de Souza

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of 1

Complete if Known

Application Number	10/539,886
Filing Date	June 17, 2005
First Named Inventor	Jaehwan EUN, et al.
Art Unit	
Examiner Name	

Attorney Docket Number DE1643

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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